



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ford B. Grigg
Kenneth N. Glover

Serial No.: 10/068,819

EXAMINER: McHenry, Kevin L.

Filing Date: 02/05/2002

Art Unit: 1725

For: SYSTEM WITH POLYMER MASKING FLUX FOR
FABRICATING EXTERNAL CONTACTS ON
SEMICONDUCTOR COMPONENTS (AS AMENDED)

Attorney Docket No. 01-0371

RECEIVED
DEC 1 2003
TC 1700

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DEC 11 2003
TC 1700

**AMENDMENT SUBMITTED WITH REQUEST FOR CONTINUED
EXAMINATION (RCE) UNDER 37 CFR 1.114**

December 5, 2003

Mail Stop RCE
Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is in response to the Office Action dated 10/23/2003 having a statutory period for response set to expire on 01/23/2004. Please amend the case as follows.